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\*\* CONTINUING DATA *None* \*\*\*\*\*

\*\* FOREIGN APPLICATIONS *Yes* \*\*\*\*\*  
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IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR  COUNTRY JAPAN	SHEETS  DRAWING 6	TOTAL  CLAIMS 12	INDEPENDENT  CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Zia R. Hashmi</i> Examiner's Signature Initials				

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## TITLE

Electron beam exposure apparatus, electron beam exposure apparatus calibration method, and semiconductor element manufacturing method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
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